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PATENTS
4448/CPS/IBSS/LAP

#11/Amend B
3-12-03
AB

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Ronald Schauer and John Charles Davies
Serial No. : 09/706,435
Filed : November 3, 2000
For : INSTALLATION DOCKING PEDESTAL FOR PRE-
FACILITATION OF WAFER FABRICATION
EQUIPMENT
Examiner : Naschica Sanders Morrison
Group Art Unit : 3632

Hon. Assistant Commissioner
for Patents
Washington, D.C. 20231

AMENDMENT

RECEIVED
FEB 27 2003
GROUP 3600

Sir:

In response to the Office Action dated August 22, 2002, it is requested that the subject application be amended as follows.

In the Claims:

Please cancel claim 20 without prejudice.

Please amend claims 1 and 21 to read as follows:

-
1. (Twice Amended) Support apparatus for an installation of semiconductor processing equipment having a

B1